

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q96773

Takeyoshi KANO, et al.

Appln. No.: 10/594,227

Group Art Unit: 1773

Confirmation No.: 3397

Examiner: Carl J. ARBES

Filed: September 25, 2006

For: METHOD FOR FORMING SURFACE GRAFT, METHOD FOR FORMING  
CONDUCTIVE FILM, METHOD FOR FORMING METHOD PATTERN, METHOD  
FOR FORMING MULTILAYER WIRING BOARD, SURFACE GRAFT MATERIAL,  
AND CONDUCTIVE MATERIAL

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement dated February 21, 2008. In response to the Restriction Requirement, Applicant elects Group III (claims 8-10, 14, 17, and 20) for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected subject matter.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

/Brett S. Sylvester/

Brett S. Sylvester

Registration No. 32,765

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: March 13, 2008